

10/587500

AP20 Rec'd PCT/PTO 27 JUL 2006

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takaaki NODA et al.

Application No.: New U.S. National Phase of
PCT/JP2005/005699

Filed: July 27, 2006

Docket No.: 128807

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND
APPARATUS FOR PROCESSING SUBSTRATE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification; and

Remarks.